

Image

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Docket No.: 0756-2077

2818

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Patent Application of )

Shunpei YAMAZAKI, et al )

Serial No. 09/466,828 )

Group Art Unit: 2818

Filed: 12/20/99 )

Examiner: Renee R. Berry

For: INSULATING FILM AND METHOD OF  
PRODUCING SEMICONDUCTOR DEVICE

**REQUEST FOR ACKNOWLEDGMENT OF  
INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
P. O. Box 1450  
Alexandria VA 22313-1450

Sir:

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with  
The United States Postal Service with sufficient postage as First  
Class Mail in an envelope addressed to: Commissioner for Patents,  
P. O. Box 1450 Alexandria VA 22313-1450, on January 29, 2004


*Renee R. Berry*

Applicants acknowledge with appreciation the Notice of Allowability and Issue Fee  
Due form mailed July 2, 2003 acknowledging the filing of an Information Disclosure  
Statement on March 3, 2003.

The Notice of Allowability did not, however, include an initialed Form PTO-1449  
acknowledging the Information Disclosure Statements filed May 10, 2002 and April 2,  
2003. Also, further Information Disclosure Statements were filed on October 2, 2003 and  
December 16, 2003. The acknowledgements of these Information Disclosure Statements  
are also outstanding. Therefore, it is respectfully requested that the Examiner evidence  
consideration of the references cited in the IDS of May 10, 2002; April 2, 2003; October 2,  
2003 and December 16, 2003 by providing a copy of the initialed Form PTO-1449.

If a conference would be beneficial in expediting the prosecution of the instant  
application, the Examiner is invited to telephone the undersigned to arrange such a  
conference.

Respectfully submitted,

  
Eric J. Robinson  
Registration No. 38,285

ROBINSON INTELLECTUAL PROPERTY LAW OFFICE, P.C.  
PMB 955  
21010 Southbank Office  
Potomac Falls, Virginia 20165  
(571) 434-6789  
(571) 434-9499 (FAX)